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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United State	s Patent Application of:) Confirmation No.:	1232
Applicant:	Baum, et al.) Docket No.:	2771-510
Application No.:	09/823,196) Examiner:	Erik J. Kieli
Date Filed:	March 30, 2001) Group Art Unit:	2813
Title:	SOURCE REAGENT COMPOSITIONS FOR CVD FORMATION OF GATE DIELECTRIC THIN FILMS USING AMIDE PRECURSORS AND METHOD OF USING SAME	Customer No.:)))))	25559

FACSIMILE TRANSMISSION CERTIFICATE

ATTN: Examiner Kielin

Fax No. (708) 273-1693

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Number of Pages (including cover) Marianne Fuierer June 29, 2005 Date

COPY OF RESPONSE TO NOVEMBER 1, 2004 OFFICE ACTION IN U.S. PATENT **APPLICATION NO. 09/823,196**

Mail Stop Amendment Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the request of Examiner Kielin, the undersigned attorney is faxing this copy directly to the Examiner, because Examiner Kielin did not receive the original submission.

In the event that any issues remain, Examiner Kielin is requested to contact the undersigned attorney at (919) 419-9350 to resolve same.

Respectfully submitted

Marianne Fuierer Registration No. 39,983 Attorney for Applicants

INTELLECTUAL PROPERTY/ **TECHNOLOGY LAW** P.O. Box 14329 Research Triangle Park, NC 27709 Phone: (919) 419-9350 Fax: (919) 419-9354 Attorney File: 2771-510

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רות	HE UNITED STATES PATENT AND IR	ADEMARK OFFICE	
in re United Stat	tes Patent Application of:	Confirmation No.:	L232
Applicant:	Beam, et al.)) Docket No.:	2778-510
Application No.:	09/823,196) } Examiner:	Brik J. Kiel
Date Filed:	March 30, 2001) } Group Art Units	2813
Title:	SOURCE REAGENT COMPOSITIONS FOR CVD FORMATION OF GATE DIFLECTRIC THEN FILMS USING AMIDE PRECURSORS AND METHOD OF USING SAME.	Customer No.:	25559
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RESPONSE TO	NOVEMBER 1, 2004 OFFICE ACTION I 19/823,196	in U.S. Patent Apple	CATION NO
Mail Stop Amenda Commissioner for I PO Box 1450 Alexandria, VA 22	Patents		 .
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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 1232 In re United States Patent Application of: Baum, et al. Docket No.: 2771-510 **Applicant:** 09/823,196 Application No.: Examiner: Erik J. Kielin March 30, 2001 Date Filed: **Group Art Unit:** 2813 SOURCE REAGENT Customer No.: Title: 25559 COMPOSITIONS FOR CVD FORMATION OF GATE DIELECTRIC THIN FILMS USING AMIDE PRECURSORS AND METHOD OF USING SAME

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ATTN: Examiner Kielin Fax No. (703) 872-9306

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on January 21, 2005, to United States Patent and Trademark Office facsimile transmission number (703) 872-9306.

Number of Pages (including cover)

Marianne Fuierer

January 21, 2005

Date

RESPONSE TO NOVEMBER 1, 2004 OFFICE ACTION IN U.S. PATENT APPLICATION NO. 09/823,196

Mail Stop Amendment Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the November 1, 2004 Office Action, please amend the application as follows: